



STIC EIC 2100 Search Request Form

(12)
105296

Today's Date:

10/02/03

What date would you like to use to limit the search?

Priority Date: 04/07/00 Other:

Name Hung Pham

AU 2172 Examiner # 78692

Room # 4D35 Phone 605 4242

Serial # 09/545,592

Format for Search Results (Circle One):

PAPER

DISK

EMAIL

Where have you searched so far?

USP

DWPI

EPO

JPO

ACM

IBM TDB

IEEE

INSPEC

SPI

Other

Is this a "Fast & Focused" Search Request? (Circle One) YES NO

A "Fast & Focused" Search is completed in 2-3 hours (maximum). The search must be on a very specific topic and meet certain criteria. The criteria are posted in EIC2100 and on the EIC2100 NPL Web Page at <http://ptoweb/patents/stic/stic-tc2100.htm>.

What is the topic, novelty, motivation, utility, or other specific details defining the desired focus of this search? Please include the concepts, synonyms, keywords, acronyms, definitions, strategies, and anything else that helps to describe the topic. Please attach a copy of the abstract, background, brief summary, pertinent claims and any citations of relevant art you have found.

S&L query
False clause or False predicate or False statement
Metadata (Retrieving or Obtaining or Extracting)

KIM VU
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2100

10-03-03 A10:49 IN

STIC Searcher Geoffrey St. Leger

Phone 308-7800

Date picked up 10/6/03

Date Completed 10/7/03





STIC Search Report

EIC 2100

STIC Database Tracking Number: 105296

TO: Hung Pham
Location: 4D35
Art Unit : 2172
Tuesday, October 07, 2003

Case Serial Number: 09/545592

From: Geoffrey St. Leger
Location: EIC 2100
PK2-4B30
Phone: 308-7800

geoffrey.stleger@uspto.gov

Search Notes

Dear Examiner Pham,

Attached please find the results of your search request for application 09/545592. I searched Dialog's foreign patent files, technical databases, product announcement files and general files; along with ACM, IBM's TDBs and the Internet.

Please let me know if you have any questions.

Regards,

Geoffrey St. Leger
4B30/308-7800



STIC Search Results Feedback Form

EIC 2100

Questions about the scope or the results of the search? Contact *the EIC searcher or contact:*

Anne Hendrickson, EIC 2100 Team Leader
308-7831, CPK2-4B40

Voluntary Results Feedback Form

➤ I am an examiner in Workgroup: Example: 3730

➤ Relevant prior art **found**, search results used as follows:

- ☐ 102 rejection
- ☐ 103 rejection
- ☐ Cited as being of interest.
- ☐ Helped examiner better understand the invention.
- ☐ Helped examiner better understand the state of the art in their technology.

Types of relevant prior art found:

- ☐ Foreign Patent(s)
- ☐ Non-Patent Literature
(journal articles, conference proceedings, new product announcements etc.)

➤ Relevant prior art **not found**:

- ☐ Results verified the lack of relevant prior art (helped determine patentability).
- ☐ Results were not useful in determining patentability or understanding the invention.

Comments:

Drop off or send completed forms to STIC/EIC2100 CPK2-4B40

